## Stress-induced phase transformations in a hotdeformed two-phase ( $\alpha_2 + \gamma$ ) TiAl alloy

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Stress-induced  $\gamma \rightarrow \alpha_2$ ,  $\alpha_2 \rightarrow \gamma$  and  $\gamma \rightarrow 9R$  phase transformations in a hot-deformed Ti-45 at % AI-10 at % Nb allov have been investigated using high-resolution transmission electron microscopy. The  $\gamma \rightarrow \alpha_2$  phase transformation is an interface-related process. The interfacial superdislocations emitted from the misoriented semicoherent  $\alpha_2 - \gamma$  interface react with each other or with the moving dislocations in the  $\gamma$  phase, resulting in the formation of the  $\alpha_2$  phase. The nucleation of the  $\alpha_2 \rightarrow \gamma$  phase transformation takes place either at the  $\alpha_2 - \gamma$ interfaces or at the stacking faults on the basal plane of  $\alpha_2$  phase, and the growth of  $\gamma$  plate is accomplished by the moving of  $a/6\langle 10\overline{1}0\rangle$  Shockley partials on alternate basal plane  $(0001)_{\alpha_2}$ . The 9R structure was usually found to form at incoherent twin or pseudotwin boundaries. During deformation the interfacial Shockley partial dislocations of these incoherent twin and pseudotwin boundaries may glide on (111), planes into the matrix, resulting in the formation of 9R structure. The interfaces (including  $\alpha_2 - \gamma$  and  $\gamma - \gamma$  interfaces) as well as the crystallographic orientation relationship between the as-received or stress-induced  $\alpha_2$ ,  $\gamma$  and 9R phase have been analysed. The mechanisms for the stress-induced  $\gamma \rightarrow \alpha_2$ ,  $\alpha_2 \rightarrow \gamma$  and  $\gamma \rightarrow 9R$  phase transformations were also discussed. © 1998 Chapman & Hall

### 1. Introduction

It is widely accepted that two-phase  $\gamma$ -TiAl alloys as viable structural materials depends strongly on the optimization of the designed microstructures which can be produced by controlled processing and appropriate alloying [1]. Recently, development of microstructures by thermomechanical treatment is under intensive investigation so as to develop balanced improvements of properties [1]. During thermomechanical processing, the lamellar structure is heavily deformed and simultaneously recrystallized; a variety of high-temperature deformation modes such as ordered twinning of the  $\{1\,1\,1\,\}\langle 1\,1\,\overline{2}\}$  type, slip on  $\{111\}\langle\overline{1}10\}$  and  $\langle\overline{1}01\rangle, \frac{1}{2}\langle11\overline{2}\rangle$  superdislocation slips occur at the same time [2-4]. Accompanying these deformation modes, there also exist some stressinduced phase transformations including  $\gamma \rightarrow 9R$ ,  $\gamma \rightarrow \alpha_2$  and  $\alpha_2 \rightarrow \gamma$  [5].

In fact, the stress-induced structural transition phenomena have been reported by some researchers in some intermetallics under high-temperature or roomtemperature deformation. Stress-induced disordering characterized as the modification of the superdislocation from fourfold to twofold and to single dislocation, and creep-induced reordering characterized as the modification of the superdislocation from twofold to fourfold, may occur in Fe<sub>3</sub>Al alloy. During creep, two opposite phenomena, i.e., strain-induced disordering and creep-induced reordering, are in competition [6]. More recently, many researchers reported that stressinduced phase transformations occur during deformation of two-phase  $\gamma$ -TiAl alloys. For example, Singh and Howe [7] observed the formation of the stressinduced 9R structure in a Ti-48.7 at % Al alloy deformed to 12% compressive strain at room temperature, Appel et al. [8] also observed the formation of 9R structure in a Ti-48.5 at % Al-1.5 at % Mn alloy deformed in tension at 900 °C, Feng et al. [9,10] reported the formation of Ti<sub>3</sub>Al phase within the primary TiAl (i.e., a stress-induced  $\gamma \rightarrow \alpha_2$  phase transformation) during deformation of XD<sup>TM</sup> (Ti-45 at % Al)-TiB<sub>2</sub> alloys, Gao et al. [11] verified the existence of such a stress-induced  $\gamma \rightarrow \alpha_2$  phase transformation in a Ti-47.5 at % Al-2.5 at % V alloy compressed at room temperature and claimed that the stress-strain curve of such a stress-induced  $\gamma \rightarrow \alpha_2$  phase transformation appears to be similar to that of stressinduced  $\beta_1 \rightarrow \gamma_1$  martensitic transformations in Cu-Al-Ni alloys and Zhang et al. [12] reported a stress-induced  $\alpha_2 \rightarrow \gamma$  phase transformation in a Ti–50

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at % Al-2 at % Mn-1 at % Nb alloy compressed to 1-2% at room temperature. However, the mechanisms of these stress-induced phase transformations in two-phase  $\gamma$ -TiAl alloys have not been studied in detail.

Ti-45 at % Al-10 at % Nb is a high-performance alloy with excellent high-temperature strength and oxidation resistance [13]. As a part of our systematic continual research on the stress-induced microstructures and phase transitions in Ti-Al-Nb ternary intermetallic alloys [13–18], in this paper, stress-induced  $\gamma \rightarrow \alpha_2$ ,  $\alpha_2 \rightarrow \gamma$  and  $\gamma \rightarrow 9R$  phase transformations in a hot-worked Ti-45 at % Al-10 at % Nb alloy with nearly fully lamellar microstructure were investigated by high-resolution transmission electron microscopy (HRTEM). The mechanisms for the stress-induced  $\gamma \rightarrow \alpha_2$ ,  $\alpha_2 \rightarrow \gamma$  and  $\gamma \rightarrow 9R$  phase transformations were also discussed.

### 2. Experimental procedure

The alloy with a composition 45 at % Ti, 45 at % Al and 10 at % Nb was prepared from high-purity Ti (99.9%), Al (99.9%) and Nb (99.9%) by non-consumable electrode arc melting in a purified argon atmosphere. The as-cast ingot was wrapped in a steel foil, heated to 1250 °C for 30 min and then quasi-isothermally forged to more than 40%. The temperature of the forge hammer was 1050 °C and the strain rate was about  $5 \times 10^{-1}$  s<sup>-1</sup>. The forged ingot was air cooled.

Transmission electron microscopy (TEM) specimens were prepared by standard twin-jet polishing and/or ion milling and examined using a JEOL-2000EXII electron microscope operating at 200 kV with a spherical aberration coefficient of 0.7 mm.

### 3. Results

The phase constitution and the microstructure of the alloy were studied previously [13, 14]. The phases in the alloy were  $\gamma$ -TiAl and  $\alpha_2$ -Ti<sub>3</sub>Al as analysed by X-ray diffraction. The microstructure of the quasiisothermal forged Ti–45 at % Al–10 at % Nb alloy observed by conventional TEM was a nearly lamellar microstructure with a high volume fraction (>95%) of lamellar colonies. During hot working, the lamellar structure is deformed and simultaneously dynamically recovered or partially recrystallized. The dynamic recrystallization of the deformed lamellar structure was found to maintain the lamellar morphology in the lamellar colonies.

# 3.1. Stress-induced $\gamma \rightarrow \alpha_2$ phase transformation

Fig. 1 shows a HRTEM image of an  $\alpha_2 - \gamma_C$  lamellar structure in  $[10\overline{1}]_{\gamma}/[11\overline{2}0]_{\alpha_2}$  orientation (here the symbols  $\gamma_A$ ,  $\gamma_B$ ,  $\gamma_C$ ,  $\gamma_D$ ,  $\gamma_E$  and  $\gamma_F$  are used to distinguish six  $\gamma$  variants with  $[\overline{1}10]$ ,  $[1\overline{1}0]$ ,  $[10\overline{1}]$ ,  $[\overline{1}01]$ ,  $[0\overline{1}1]$  and  $[01\overline{1}]$  orientations, respectively [19, 20]). The interface between the  $\alpha_2$  and  $\gamma_C$  phases is a misoriented semicoherent interphase boundary with the

Figure 1 HRTEM image of a deviating semicoherent  $\alpha_2 - \gamma$  interface with deviation angle  $\theta = 2.5^{\circ}$ , i.e., the orientation relationship between the  $\gamma$  and the  $\alpha_2$  phase is  $[10\bar{1}]_{\gamma}/[11\bar{2}0]_{\gamma_2}$  and  $(111)_{\gamma} \wedge (0001)_{\alpha_2} \approx 2.5^{\circ}$ .

 $(111)_{\gamma}$  plane misoriented by  $\theta = 2.5^{\circ}$  from the  $(0001)_{\alpha_2}$ , i.e., the orientation relationship between the  $\gamma$  and  $\alpha_2$  phase is  $[10\overline{1}]_{\gamma}/[11\overline{2}0]_{\alpha_2}$  and  $(111)_{\gamma} \wedge (0001)_{\alpha, \gamma} \approx 2.5^{\circ}$ . Ledges that were three  $(111)_{\gamma}$  or  $(0001)_{\alpha}$  atomic planes high were observed and some ledges are indicated by arrows in Fig. 1. The deviation arises from the climb component of the ledge dislocation:  $\frac{1}{3}$  [111] Frank partials. This can be considered to arise because the  $\alpha_2 - \gamma$  interface can absorb the slipping dislocations in the  $\gamma$  phase as a dislocation sink to adjust the deformation. The characteristics of ledge dislocations at the interface have been determined as  $\frac{1}{2} [101] \rightarrow \frac{1}{6} [1\overline{2}1] + \frac{1}{3} [111]$ , i.e., 90° Shockley partial dislocation  $+\frac{1}{3}$  [111] Frank partial dislocation [14, 15]. It can be seen from Fig. 1 that the dislocation ledges contain  $\frac{1}{3}$  [111] Frank partial dislocations (see arrows in Fig. 1). The mean distances of these ledges are about 4.6 nm. A dark contrast near the ledges reveals that there exist high stresses which are associated with the Frank-type dislocations.

Fig. 2a shows a lamellar structure composed of  $\gamma_{\rm C} - \gamma_{\rm D} - \alpha_2$ , where the  $\gamma_{\rm D} - \alpha_2$  interface is also a misoriented semicoherent  $\alpha_2 - \gamma$  interface with the deviation angle  $\theta = 2.5^{\circ}$ . Above this interface, a thin stress-induced  $\alpha_2$  plate (here referred to as DI- $\alpha_2$ ) about 25 nm long and 2.5 nm thick forms in the  $\gamma_{\rm D}$  lamellae; meanwhile the  $\gamma$  phase between the  $\alpha_2$  lamella and the DI- $\alpha_2$  plate changes from  $\gamma_D$  to  $\gamma_B$ . Fig. 2b is the enlarged view of the region containing DI- $\alpha_2$ . Both the orientation relationships between  $\gamma_{\rm B}$  and as-received  $\alpha_2$  and the orientation relationships between  $\gamma_{\rm B}$  and DI- $\alpha_2$  are nearly exactly  $[1\overline{1}0]_{\gamma}//$  $[11\overline{2}0]_{\alpha_2}$  and  $(111)_{\gamma}/(0001)_{\alpha_2}$ . However, the orientation relationship between DI- $\alpha_2$  and as-accepted  $\gamma_D$  is not exactly  $[\overline{1}01]_{\gamma}/[11\overline{2}0]_{\alpha}$ , and  $(111)_{\gamma}/((0001)_{\alpha})$ ; a deviation angle  $\theta \approx 2.5^{\circ}$  existed between the  $(1\ 1\ 1)_{\gamma_{\rm p}}$ and the  $(0001)_{DI-\alpha_2}$  plane. Also, there is a similar deviation angle between  $(1 \ 1 \ 1)_{\gamma_{\rm B}}$  and  $(1 \ 1 \ 1)_{\gamma_{\rm D}}$  planes.  $\frac{1}{3}$ [111] Frank partial dislocations are observed at both the  $\gamma_D$ -DI- $\alpha_2$  interface and the  $\gamma_D$ - $\gamma_B$ boundary.

Fig. 3a shows a well-grown DI- $\alpha_2$  plate near the misoriented semicoherent  $\alpha_2 - \gamma_D$  interface. It is about 5 nm thick and as long as the whole image. Also, the  $\gamma$  phase between the  $\alpha_2$  lamellae and the DI- $\alpha_2$  plate changes from  $\gamma_D$  to  $\gamma_B$ , and it is divided into many blocks by stacking faults on  $(1\overline{1}1)$  plane which are



*Figure 2* (a) HRTEM image showing a thin deformation-induced  $\alpha_2$  plate (here referred to as DI- $\alpha_2$ ) formed in the  $\gamma$  lamellae near a deviating semicoherent  $\alpha_2$ - $\gamma$  interface with deviation angle  $\theta = 2.5^{\circ}$ ; (b) the enlarged view of the region containing DI- $\alpha_2$ .

either associated with a ledge at the  $\gamma_B$ -DI- $\alpha_2$  interface or suspended in the  $\gamma_B$  phase. The enlargement of regions A, B and C in Fig. 3a are shown in Fig. 3b, c and d, respectively, where region A is the area containing the "tip" of the stress-induced  $\alpha_2$  plate and region C is the area containing many stacking faults terminated at the middle of the  $\gamma_{\rm B}$  phase. (In fact, beyond the stacking faults the  $\gamma$  phase between the DI- $\alpha_2$  and the  $\alpha_2$  phases still remains as  $\gamma_D$ ). From Fig. 3b, it can be seen that there exist many ledges at the DI- $\alpha_2 - \gamma_B$  interface, and each ledge is associated with a stacking fault on  $(1\overline{1}1)$  plane; also  $\frac{1}{3}[111]$ Frank partial dislocations can be observed either on the DI- $\alpha_2 - \gamma_D$  interface or at the ledge of the DI- $\alpha_2 - \gamma_B$ interface. The "tip" of the  $DI-\alpha_2$  plate, which is indicated by a black arrowhead in Fig. 3b, is actually a stacking fault on the (111) plane. A stacking fault on the (111) plane accompanying a climb of a  $\frac{1}{3}$  [111] Frank partial dislocation, which is emitted from the misoriented semicoherent  $\alpha_2$ - $\gamma$  interfaces, intersects the stacking fault on the  $(1\overline{1}1)$  plane. In Fig. 3d, many stacking faults on  $(1\overline{1}1)$  planes stemming from the ledges on the misoriented semicoherent  $\alpha_2 - \gamma$  interface terminate in the middle part of the  $\gamma$  phase. Accompanying the propagation of these stacking faults into the  $\gamma$  phase on the  $(1\overline{1}1)$  planes,  $\frac{1}{3}$  [111] Frank partial dislocations are also observed to climb along the  $(1\overline{1}1)$  plane from the misoriented semicoherent  $\alpha_2 - \gamma$ interface into the  $\gamma$  phase. This means that the stressinduced  $\gamma \rightarrow \alpha_2$  phase transformation is an interphase interface-related process. The structure of the dislocation ledges on the misoriented semicoherent  $\alpha_2 - \gamma$ interface is expected to play an important role in the formation of the stress-induced  $\alpha_2$  phase plate, and this will be discussed below.



*Figure 3* (a) HRTEM image showing a well-grown DI- $\alpha_2$  plate near the deviating semicoherent  $\alpha_2 - \gamma_D$  interface; (b), (c) and (d) enlargements of the regions A, B and C, respectively, in (a).

# 3.2. Stress-induced $\alpha_2 \rightarrow \gamma$ phase transformation

In Fig. 4a the  $\alpha_2$  lamellae is separated into two parts by a stress-induced  $\gamma(DI-\gamma)$  plate. This DI- $\gamma$  phase plate is nucleated during deformation at the misoriented semicoherent  $\alpha_2 - \gamma_D$  interface and penetrates into the  $\alpha_2$  phase. The orientation relationship between the  $\alpha_2$  and the DI- $\gamma$  plate is exactly  $[11\overline{2}0]_{\alpha_2}//[10\overline{1}]_{DI-\gamma}$  and  $(0001)_{\alpha_2}//((111)_{DI-\gamma})$ . The (111) plane of  $\gamma_{\rm D}$  and the (111) plane of DI- $\gamma$  enclose an angle of about 2.5°. Fig. 4b shows the tip of the DI- $\gamma$  plate. Rather high stresses exist in this area so that it is very difficult to obtain a well-resolved HRTEM image. At the tip of the DI- $\gamma$  plate, stackingfault fringes can be seen in the  $\alpha_2$  matrix (see arrowheads). Also, it can be seen that these stacking fault fringes penetrate into the  $\alpha_2$  matrix in coordination. This means that the  $\alpha_2 \rightarrow DI-\gamma$  transformation is accomplished by the glide of  $(a/6\langle 10\overline{1}0\rangle$  Shockley partials on the alternate basal plane  $(0001)_{\alpha}$ , and the  $(a/6)\langle 10\overline{1}0\rangle$  Shockley partials move in coordination

rather than to sweep on the  $(0001)_{\alpha_2}$  plane one by one.

Fig. 5a shows a HRTEM image of a deformed  $\alpha_2$  lamellae in the  $\langle 1 \ 1 \ \overline{2} \ 0 \rangle_{\alpha_2}$  orientation. Three stacking faults A, B and C on the  $(0 \ 0 \ 0 \ 1)_{\alpha_2}$  plane are observed. Stacking fault C is a simple stacking fault, while at the middle part of stacking faults A and B there exist three or four layers of the basal planes in the ABC... stacking sequence, respectively (see Fig. 5b and c). In fact such an ABCABC... stacking sequence would result in a structure change from  $\alpha_2$  to face-centred cubic (f.c.c.). Also, in Fig. 5a, a well-grown DI- $\gamma$  (as indicated at D) can be seen; the "head" of this DI- $\gamma$  plate is observed to be stacking faults of  $\alpha_2$  phase (see arrowheads).

# 3.3. Stress-induced $\gamma \rightarrow 9R$ structures 3.3.1. Observation of the 9R structure

Three kinds of interface can be formed between two lamellae of either variant: true twin boundary ( $\gamma_A - \gamma_B$ 



*Figure 4* (a) HRTEM image showing a DI- $\gamma$  phase plate formed at the deviating semicoherent  $\alpha_2 - \gamma_D$  interface penetrating into the  $\alpha_2$  phase; (b) HRTEM image showing the tip of the DI- $\gamma$  plate.



*Figure 5* (a) HRTEM image of a deformed  $\alpha_2$  lamellae in the  $\langle 1 \, 1 \, 2 \, 0 \rangle_{\alpha_2}$  orientation showing DI- $\gamma$  laths formed at stacking faults on the  $(000\,1)_{\alpha_2}$  planes of the  $\alpha_2$  phase; (b) and (c) enlargements of stacking faults A and B, respectively in (a) showing four and three layers of the basal planes in the ABC... stacking sequence.



*Figure 6* HRTEM images of the 9R structure formed (a), (b) at multiple-height ledges of pseudotwin boundaries and (c), (d) at multiple-height ledges of twin boundaries.

or  $\gamma_{\rm C} - \gamma_{\rm D}$ ), pseudotwin boundary ( $\gamma_{\rm A} - \gamma_{\rm D}$  or  $\gamma_{\rm B} - \gamma_{\rm C}$ ) and 120°-rotation-type boundary ( $\gamma_A - \gamma_C$  or  $\gamma_B - \gamma_D$ ) [14, 15, 19, 20]. Fig. 6 shows HRTEM images of various  $\gamma$  variants and stress-induced structures with a threeplane periodicity (hereafter referred to as 9R) in the quasi-isothermally forged sample. Fig. 6a shows a pseudotwin  $\gamma_D - \gamma_A$  boundary; the 9R structure is observed to be located at multiple-height ledges of the pseudotwin boundary. Fig. 6b shows a lamellar structure composed of four  $\gamma$  variants. Two  $\gamma$  variants  $\gamma_{\rm D} - \gamma_{\rm C}$  on the left-hand side of the figure are in a true twin relationship while, on the right-hand side of the figure, there are three  $\gamma$  variants  $\gamma_B - \gamma_A - \gamma_B$  which are also in true twin relationship. Two regions with the 9R struture are formed between variants  $\gamma_{\rm B}$  and  $\gamma_{\rm C}$  which have a pseudotwin relationship. Both regions with the 9R structure seem to be located at multiple-height ledges of the pseudotwin boundary. In Fig. 6c,  $\gamma_A$  and  $\gamma_B$  are twin-related variants; the 9R structure is formed at the head of the  $\gamma_B$  lamella. In Fig. 6d, all the lamellae are twin-related  $\gamma$  variants ( $\gamma_{\rm C}$  or  $\gamma_{\rm D}$ ) and three regions showing a 9R structure are observed to be formed at multiple-height ledges of the twin boundaries.

From the above analysis of Fig. 6 we find the following.

(a) The 9R structure was always formed parallel to the primary twin plane, i.e., it was never observed along a conjugate slip plane. The occurence of the 9R structure parallel to the twin indicates that the primary slip plane is the easiest direction of deformation.

(b) The 9R structure was always formed at the multiple-height ledges of either twin or pseudotwin boundaries. That is the  $\gamma$  variants at both sides of the 9R structure are either twin-related or pseudo-twin-related ordered variants of  $\gamma$ -TiAl. In the crystal-lography, the multiple-height ledges of a twin or pseudotwin boundary are called an incoherent twin or incoherent pseudotwin boundary.

#### 3.3.2. Crystallographic structure of the 9R

Fig. 7 is the enlargement of the 9R structure in Fig. 6b. The 9R structure may be considered as a close-packed structure with stacking faults on every third closepacked plane in the f.c.c. structure. The stacking sequence is ABC/BCA/CAB/A... A schematic diagram is shown in Fig. 8.

The selected-area electron diffraction pattern (SADP) taken from the region containing  $\gamma_{C}$ ,  $\gamma_{D}$  and 9R structure in Fig. 6d is shown in Fig. 9a. Fig. 9b gives the schematic index for Fig. 9a. According to the SADP, the orientation relationship between the 9R structure and the  $\gamma$ -TiAl matrix can be determined as



Figure 7 Demonstration of the stacking sequence of the enlarged 9R structure of Fig. 1b; the random stacking faults in 9R structure are also shown (indicated by arrowheads).



Figure 8 Atomic arrangement of the 9R structure in the [010] projection. ( $\bullet$ ), Ti (z = 0); ( $\bigcirc$ ), Al (z = 0.5).

follows:

### $[010]_{9R}/[10\overline{1}]_{\gamma}, (001)_{9R}//(111)_{\gamma}.$

The 9R structure is an orthorhombic structure. Since the  $(001)_{9R}$  planes are the basal planes of the orthorhombic unit cell, it is possible to estimate the lattice parameters for the 9R structure from Figs 8 and 9, based upon the lattice parameter ratio given by Nishiyama and Kajiwara [21] for a perfect 9R structure namely a:b:c = 1.732:1:7.348 ( $=3^{1/2}:1:3 \times 6^{1/2}$ ). Not accounting for the tetragonality of  $\gamma$ , choosing the lattice parameters to be a = c = 4.02A, and applying the Nishiyama–Kajiwara ratio yield the following unit-cell parameters for the 9R structure:

$$c_{9R} = 9d_{(111)_{\gamma}} = 3^{3/2}a_{\gamma} = 20.8 \text{ Å}$$
$$a_{9R} = d_{(100)_{9R}} = \frac{6^{1/2}}{2}a_{\gamma} = 4.90 \text{ Å}$$
$$b_{9R} = d_{(010)_{9R}} = d_{(101)\gamma} = 2.82 \text{ Å}$$



*Figure 9* (a) SADP taken along the  $[0\,1\,0]_{9R}/[1\,0\,\overline{1}]_{\gamma}$  direction; (b) the schematic index of (a).

#### 4. Discussion

### 4.1. Mechanism of the stress-induced $\gamma \rightarrow \alpha_2$ phase transformation

The observations in Section 3.1 show that the formation of the DI- $\alpha_2$  plate is near the misoriented semicoherent  $\alpha_2 - \gamma_D$  interface and is an interfacialrelated process. As reported in other works [14, 15] and from Fig. 1, there exist many dislocation ledges on the misoriented semicoherent  $\alpha_2 - \gamma$  interface and the dislocation characteristic of the ledge is a superdislocation  $(\frac{1}{2} \lceil 101 \rceil \text{ or } \frac{1}{2} \lceil 011 \rceil)$  or a common dislocation  $(\frac{1}{2} \begin{bmatrix} 1 \\ 1 \end{bmatrix})$  composed of a  $\frac{1}{3} \begin{bmatrix} 1 \\ 1 \end{bmatrix}$  Frank partial and a Shockley partial. Under deformation the moving dislocations in  $\gamma$  phase can be absorbed at the  $\alpha_2 - \gamma$ interfaces, resulting in the rearrangement of the mismatch interfacial dislocations to accomodate the new interfacial misfit; then density of ledges can be increased and the misoriented semicoherent  $\alpha_2 - \gamma$  interfaces can be formed [14, 15]. Furthermore, during thermomechanical deformation process, the dislocations on the misoriented semicoherent  $\alpha_2 - \gamma$  interfaces can be emitted from the interface into  $\gamma$  phase by adjusting the deformation of the  $\alpha_2 + \gamma$  two-phase alloy. Based on this point, the following dislocation mechanism is proposed for interfacial-related stressinduced  $\gamma \rightarrow \alpha_2$  phase transformation.

Under deformation, the interfacial superdislocation  $\frac{1}{2}[\overline{1}01]$  can move from the interface along  $(1\overline{1}1)$  plane, resulting in the change of  $\gamma_D$  to  $\gamma_B$ . Meanwhile, the interfacial  $\frac{1}{3}[111]$  Frank partial dislocation can climb into the  $\gamma$  phase under thermomechanical deformation. Since the  $(1\overline{1}1)$  plane is not a primary slip

plane, after a short distance slip on  $(1\overline{1}1)$  plane the  $\frac{1}{2}[\overline{1}01]$  superdislocation would move to the (111) primary slip plane through cross-slip and would be dissociated on the (111) plane as follows:

$$\frac{1}{2} [\overline{1} 0 1] \rightarrow \frac{1}{6} [\overline{2} 1 1] + \frac{1}{6} [\overline{1} \overline{1} 2]$$

The resulting  $\frac{1}{6}[\overline{2}11]$  Shockley partial dislocation can react with the  $\frac{1}{3}[111]$  Frank partial dislocation producing another superdislocation  $\frac{1}{2}[011]$ . The  $\frac{1}{6}[\overline{1}\overline{1}2]$  Shockley partial dislocation will slip on the primary slip plane (111), resulting in the formation of the stress-induced  $\gamma \rightarrow \alpha_2$  phase transformation.

After producing the  $\frac{1}{6}[\overline{1}\ \overline{1}\ 2]$  Shockley partial dislocations, the first layer of  $\alpha_2$  plate was formed by introducing one Shockley partial on a (1 1 1) plane. Subsequent  $\alpha_2$  layers were created by introducing additional Shockley partials of the same type on every other (1 1 1) plane.

In fact, the sweep of  $\frac{1}{6}[\overline{1}\,\overline{1}\,2]$  Shockley partials on the alternate (111) plane can only induce the structure change from  $L1_0$  to a hexagonal close packed (h.c.p.). This h.c.p. structure is not a perfect  $\alpha_2$  phase for its composition is lean for Ti atoms. Thus, during the stress-induced  $\gamma \rightarrow \alpha_2$  transformation process, a change to a perfect  $\alpha_2$  phase will need a local short-range diffusion of atoms simultaneously. If, after the generation of the h.c.p. structure, a local shortrange diffusion occurs, the h.c.p. plate may gain Ti atoms to change to a perfect  $\alpha_2$  phase, and the composition change results in a change in lattice constants and also interfacial dislocations are introduced to accomodate the misfit in the interface. So, it is probable that the existence of interfacial dislocations can be used to distinguish whether atom transportation occurs. In the present study, when the DI- $\alpha_2$  plate is small or in its initial stage, the DI- $\alpha_2$ - $\gamma_B$  and  $\gamma_B$ - $\alpha_2$ interfaces are nearly free from dislocation ledges (see Fig. 2). When the DI- $\alpha_2$  plate is well grown, the DI- $\alpha_2 - \gamma_B$  and  $\gamma_B - \alpha_2$  interfaces have many dislocation ledges (see Fig. 3). This means that, at the initial stage of the stress-induced  $\gamma \rightarrow \alpha_2$  transformation, no atom transportation occurs, while the DI- $\alpha_2$  grows to some stage a local short-range or long-range diffusion of atoms occurs.

# 4.2. Mechanism of the stress-induced $\alpha_2 \rightarrow \gamma$ phase transformation

From Fig. 4, it can be concluded that the nucleation of the DI- $\gamma$  plate occurs at the  $\alpha_2-\gamma$  interface, and the growth of the DI- $\gamma$  plate occurs via the propagation of  $\frac{1}{6}\langle 10\bar{1}0\rangle$  Shockley partials moving on the alternate  $(0001)_{\alpha_2}$  planes in coordination. In the situation in this study, the DI- $\gamma$  plate was nucleated at the misoriented semicoherent  $\alpha_2-\gamma_D$  interface. According to the work of Zhao and Tangri [22] and Wunderlich *et al.* [23], at the  $\alpha_2-\gamma$  interface, not only TiAl but also Ti<sub>3</sub>Al contain interfacial dislocations which accommodate the lattice misfit between both phases. The interfacial dislocations which are contained in the Ti<sub>3</sub>Al phase of a misoriented semicoherent  $\alpha_2-\gamma_D$  interface are mainly  $(\frac{a}{6})\langle 11\bar{2}0\rangle$  partials for the  $\frac{1}{3}$ [111] Frank partials are predominantly in the TiAl phase. During deformation, the  $(\frac{a}{6})\langle 11\overline{2}0\rangle$  can be emitted from the interface and undergoes the following dissociation:

$$(\stackrel{a}{_{6}})\langle 1\,1\,\overline{2}\,0\rangle \rightarrow (\stackrel{a}{_{6}})\langle 1\,0\,\overline{1}\,0\rangle + (\text{APB} + \text{SISF})$$

$$+ \left(\frac{a}{6}\right) \langle 0 1 \overline{1} 0 \rangle$$

where APB is an antiphase boundary and SISF is a superlattice intrinsic stacking fault. The reaction occurs on every other  $\alpha_2$  basal plane and, in the present situation, eight reactions occur on the  $\alpha_2$  basal planes resulting in eight  $(\frac{a}{6})\langle 10\overline{1}0\rangle$  Shockley partials on the alternate  $(0001)_{\alpha}$ , planes; then they move in coordination into the  $\alpha_2$  phase on the  $\alpha_2$  basal planes, so that the structure change of  $\alpha_2$  to f.c.c. is generated. The stacking sequence of  $(0001)_{\alpha}$ , planes ABAB... is altered to that of  $(1 \ 1 \ 1)_{f.e.e.}$  planes ABCABC ... . The f.c.c. structure must gain Al atoms to adopt the composition of the  $\gamma$  phase. A local short-range diffusion will be needed. Zhang et al. [12] claimed that no atomic transportation is involved and that the DI- $\gamma$ phase is lean in Al. For the shown DI- $\gamma$  lath, the DI- $\gamma - \alpha_2$  interface is free from ledges. This means that few interfacial dislocations are introduced to accommodate the misfit in the interface which mainly results from the tetragonality of the  $\gamma$  phase. So it appears that there is no atom transportation during this stressinduced  $\alpha_2 \rightarrow \gamma$  transformation, for the composition change would result in the tetragonality of DI-y plate (a c/a ratio larger than one) and this would introduce interfacial dislocations in the DI- $\gamma-\alpha_2$  interface.

Fig. 5 provides further evidence for a stress-induced  $\alpha_2 \rightarrow \gamma$  transformation. The nucleation of the DI- $\gamma$  plate is from the stacking fault on the basal plane of the  $\alpha_2$  phase. Such a stress-induced feature may be attributed to the movement of the  $(\frac{a}{6})\langle 10\bar{1}0\rangle$  Shockley partials on the alternate  $(0001)_{\alpha_2}$  planes induced by some particular deformation mechanisms. Since the DI- $\gamma$  plate is only three or four layers thick, it is conceivable that no long-range atomic transport is needed for such a stress-induced  $\alpha_2 \rightarrow DI-\gamma$  transformation. Further work is being carried out to characterize the process in more detail.

# 4.3. Formation mechanism of the 9R structure

As indicated in Section 3.3, the 9R structure was always found to have formed at incoherent twin or incoherent pseudotwin boundary. The interfacial dislocation structures of these incoherent twin and incoherent pseudotwin boundaries can account for the formation of the 9R structure.

If we neglect the tetragonality of the L1<sub>0</sub> structure of  $\gamma$ -TiAl, we can treat incoherent twin or incoherent pseudotwin boundaries of  $\gamma$ -TiAl as that of a f.c.c. structure. Fig. 10 illustrates the atomic structure of an incoherent twin boundary in the  $\gamma$ -TiAl phase viewed along a  $[1\bar{1}0]_m/[\bar{1}10]_T$  direction. Following the analysis procedure of the Read circuit construction for the determination of the Burgers vectors of the grainboundary dislocations [24], here a Read circuit is constructed so that the closure failure from F<sub>2</sub> to



*Figure 10* Schematic representation of an incoherent twin boundary. The Read circuit construction for the determination of the Burgers vectors of the grain-boundary dislocations is also shown.

 $F_1$  is defined as the Burgers vector of the grain-boundary dislocation in the "start to finish - right hand" sense. The dislocation arrangement in this grain boundary is identified by the closure failure. In this representation the incoherent twin boundary is seen to be a symmetrical tilt boundary consisting of a stack of edge dislocations with a lattice Burgers vectors. The net Burgers vector of the grain-boundary dislocation, i.e., the vector connecting  $F_2$  and  $F_1$ , is  $2 \times \frac{1}{6} [1 \ 1 \ \overline{2}]$ . One of the two Shockley partial dislocations is in the twin and one belongs to the matrix. During deformation the interfacial Shockley partial dislocation in the matrix may glide on a  $(111)_{\nu}$  plane into the matrix. As inferred from Fig. 10 the spacing D between the regularly spaced interfacial Shockley partial dislocations is three  $(1 \ 1 \ 1)_{\gamma}$  atomic planes and, then, during deformation a Shockley partial is moved on every third  $\{1\,1\,1\}_{y}$ plane, giving rise to the observed stacking sequence (Figs 7 and 8) of the 9R structure. Therefore, the 9R structure can be produced by the glide of these regularly spaced Shockley parital dislocations located on an incoherent twin boundary on every third closepacked plane.

# 4.4. Random stacking faults in the 9R structure

The 9R structure can be considered to consist of a periodic array of hexagonal stacking on every third close-packed plane in a perfect f.c.c. stacking sequence. Additional stacking faults can occur randomly on close-packed planes in the 9R structure. Such random stacking faults were identified in the HTREM images (Fig. 6) by variations in the regular 9R fringes with the three-layer modulation seen parallel to the basal planes.

According to the analysis of previous studies [25–28], a number of different random stacking faults are possible for the 9R structure. These are shear- and sequence-type faults, which are distinguished by the

mechanism for their formation. They can be hexagonal-, cubic- or twin-type faults, which are distinguished by the local stacking structure in the vicinity of the fault. Dark-field TEM investigations [25] and direct imaging using HRTEM [26–28] both revealed cubic- and hexagonal-type sequence faults on the 9R basal planes of Cu-based alloys but failed to find evidence for twin-type sequence faults or any shear-type faults. Cubic or hexagonal faults produce a fringe spacing of four or two layers, respectively, at the position of the fault in HRTEM images.

From the enlarged HRTEM images of the 9R structure in Fig. 7, it is possible to distinguish regions in the 9R fringe patterns where the three-layer spacing is replaced by a two-layer spacing (indicated by arrowheads). This indicates that random stacking faults are present within the 9R structure.

### 5. Conclusions

Stress-induced  $\gamma \rightarrow \alpha_2$ ,  $\alpha_2 \rightarrow \gamma$  and  $\gamma \rightarrow 9R$  phase transformations in a hot-worked Ti-45 at% Al-10 at% Nb alloy with nearly fully lamellar microstructure were investigated by HRTEM.

1. The stress-induced  $\gamma \rightarrow \alpha_2$  phase transformation is an interface-related process. The interfacial superdislocations emitted from the misoriented semicoherent  $\alpha_2 - \gamma$  interface react with each other or with the moving dislocations in the  $\gamma$  phase, resulting in the formation of the stress-induced  $\alpha_2$  phase. Meanwhile, the orientation of the  $\gamma$  phase, with an interface along which the interfacial superdislocation moves, was also changed. The structure of the dislocation ledges plays an important role in the formation of the stressinduced  $\alpha_2$  phase.

2. The observed stress-induced  $\alpha_2 \rightarrow \gamma$  phase transformation can either be nucleated at  $\alpha_2 - \gamma$  interfaces or at the stacking faults on the basal plane of the  $\alpha_2$  phase. The growth of the DI- $\gamma$  plate is accomplished by the glide of  $(\frac{a}{6}) \langle 10\bar{1}0 \rangle$  Shockley partials on the alternate basal plane  $(0001)_{\alpha_2}$  and the  $(\frac{a}{6}) \langle 10\bar{1}0 \rangle$  Shockley partials move in coordination rather than on the  $(0001)_{\alpha_2}$  plane one by one. It appears that there is no atom transportation during the stress-induced  $\alpha_2 \rightarrow \gamma$  transformation.

3. The 9R structure was always found to form at incoherent twin or incoherent pseudotwin boundaries. During deformation, interfacial Shockley partial dislocations on these incoherent twin and incoherent pseudotwin boundaries may glide on  $(111)_{\gamma}$  planes into the matrix, resulting in the formation of the 9R structure. Random stacking faults can occur within the 9R structure.

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### References

- 1. Y. W. KIM, J. Metals 46 (1994) 30.
- 2. Y. W. KIM and D. M. DIMIDUK, ibid. 43 (1991) 40.
- 3. M. A. MORRIS, Phil. Mag. A 68 (1993) 237, 259.
- M. YAMAGUCHI and H. INUI, in: "Structural intermetallics", edited by R. Darolia, J. J. Lewandawski, C. T. Liu, P. L. Martin, D. B. Miracle and M. V. Nathal (The Minerals, Metals and Materials Society, New York, 1993) p. 127.
- J. G. WANG, PhD thesis, University of Science and Technology Beijing, Beijing (1994).
- G. L. CHEN, Y. D. HUANG, W. Y. YANG and Z. Q. SUN, in: "Processing, properties and applications of Fe<sub>3</sub>Al based aluminides", edited by J. H. Schneibel and M. A. Crimp, Metallurgical Society of AIME, Warendale, PA, (1994) p. 131.
- 7. S. R. SINGH and J. M. HOWE, *Phil. Mag. Lett.* 65 (1992) 233.
- 8. F. APPEL, P. A. BEAVEN and R. WAGNER, Acta Metall. Mater. 41 (1993) 1721.
- C. R. FENG, D. J. MICHEL and C. R. CROWE, Scripta Metall. 23 (1989) 241.
- 10. C. R. FENG, D. J. MICHEL and C. R. CROWE, *Mater. Sci. Engng.* A145 (1991) 257.
- 11. Y. GAO, J. ZHU, H. SHEN and Y. WANG, Scripta Metall. Mater. 28 (1993) 651.
- 12. Y. G. ZHANG, F. D. TICHEAAR, F. W. SCHAPINK, Q. XU and C. Q. CHEN, *ibid.* **32** (1995) 981.
- G. L. CHEN, W. J. ZHANG, Y. D. WANG, J. G. WANG and Z. Q. SUN, in "Structural intermetallics", edited by R. Darolia, J. J. Lewandawski, C. T. Liu, P. L. Martin, D. B. Miracle and M. V. Nathal (The Minerals, Metals and Materials Society, New York, 1993) p. 319.
- 14. G. L. CHEN, J. G. WANG, L. C. ZHANG and H. Q. YE, Acta Metall. Sin. (Engl. Lett.) 8 (1995) 273.

- 15. J. G. WANG, L. C. ZHANG, G. L. CHEN and H. Q. YE, unpublished research (1996).
- J. G. WANG, G. L. CHEN, L. C. ZHANG and H. Q. YE, in Proceedings of Second International Symposium on Structural Intermetallics, Seven Springs, 1997, submitted.
- 17. J. G. WANG, L. C. ZHANG, G. L. CHEN and H. Q. YE, Scripta Metall. Mater. **37** (1997) 135.
- J. G. WANG, G. L. CHEN, L. C. ZHANG and H. Q. YE, Mater. Lett. 31 (1997) 179.
- 19. Y. S. YANG and S. K. WU, Scripta Metall. Mater. 24 (1990) 1801.
- 20. Y. S. YANG and S. K. WU, Phil. Mag. A 65 (1992) 15.
- 21. Z. NISHIYAMA and S. KAJIWARA, Jpn. J. Appl. Phys. 2 (1963) 478.
- 22. L. R. ZHAO and K. TANGRI, Phil. Mag. A 64 (1991) 361.
- 23. W. WUNDERLICH, T. KREMSER and G. FROMMEYER, Z. Metallkde 81 (1990) 802.
- 24. J. P. HIRTH and R. W. BALLUFFI, Acta Metall. 21 (1973) 929.
- 25. M. ANDRADE, M. CHANDRASEKARAN and L. DELAEY, *ibid.* 32 (1984) 1809.
- 26. J. M. COOK, M. A. O'KEEFE, D. J. SMITH and M. W. STOBBS, J. Microsc. **129** (1983) 295.
- 27. F. C. LOVEY, Acta Metall. 35 (1987) 1103.
- P. J. OTHEN, M. L. JENKINS and G. D. W. SMITH, *Phil. Mag. A* 70 (1994) 1.

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